

<u>Title:</u>	<i>Introduction to Focused Particle Beam Technology</i>
<u>Training duration:</u>	<i>2 days</i>
<u>Training cost:</u>	<i>Groups of 1 – 5 trainees, US\$2400 per group</i>
<u>Background required:</u>	<i>Technical degree or equivalent knowledge of physics</i>
<u>Student Objective:</u>	<i>Understanding basic principles of focused particle beam technology, image formation and practical applications to gas-assisted milling and material deposition.</i>
<u>Equipment:</u>	<i>Micrion 2000, 2500, 9000, 9100, 986, 986FC, Vectra 986(+), VectraVision, any FIB, FEB, SEM</i>
<u>Syllabus:</u>	<i>Available online: www.partbeamsystech.com/training.html</i>